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Bib Data Sheet

CONFIRMATION NO. 9869

| | | | | | |
|--|---|--|-------------------------------|---|--------------------------------|
| SERIAL NUMBER 09/732,393 | FILING DATE 12/07/2000 RULE | CLASS 252 | GROUP ART UNIT 2811 | ATTORNEY DOCKET NO. 09792909-4719 | |
| APPLICANTS Kunihiro Take, Kanagawa, JAPAN; | | | | | |
| ** CONTINUING DATA ***** <i>Name VR VB</i> | | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN P11-348080 12/07/1999 <i>Yes VR VB</i> | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/23/2001 | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <i>Allowance</i> Verified and <i>VR VB</i> Acknowledged <i>VR VB</i> | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 7 | TOTAL CLAIMS 1 | INDEPENDENT CLAIMS 1 |
| ADDRESS 26263 | | | | | |
| TITLE Semiconductor wafer examination system | | | | | |
| FILING FEE RECEIVED 840 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | | | |
| | | <input type="checkbox"/> All Fees | | | |
| | | <input type="checkbox"/> 1.16 Fees (Filing) | | | |
| | | <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) | | | |
| | | <input type="checkbox"/> 1.18 Fees (Issue) | | | |
| | | <input type="checkbox"/> Other _____ | | | |
| | | <input type="checkbox"/> Credit | | | |